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Table of Contents

An Analysis of Material Choices for Capacitive Microaccelerometers.....	1
<i>Yu. Kushnir, V. Teslyuk, P. Turchenko</i>	
An Intelligent BIST Mechanism for MEMS Fault Detection	2
<i>Jafar Tanha, Reza Asgary</i>	
An optimization procedure for a fiber optic accelerometer	5
<i>Teodor Lucian Grigorie</i>	
Analysis and Optimization of MEMS Electrostatic Microactuator	10
<i>V. Behjat, A. Vahedi</i>	
Analysis of methods for substance detection in the controlled environment.....	16
<i>Ulyana. Marikutsa</i>	
BioMEMS and Molecular Processing: Engineering Biomimetics in Design of MEMS and Processing Platforms	19
<i>Marina Alexandra Lyshevski, Sergey Edward Lyshevski</i>	
Competitiveness Ensuring for Microelectronic Industry	27
<i>N. Tkachenko</i>	
Design and Fabrication of Microactuators and Sensors for MEMS	28
<i>Ivan Puchades, Robert Pearson, Lynn F. Fuller, Sara Gottermeier, Sergey E. Lyshevski</i>	
Design and simulation of a High-Q, Low Motional Resistance, Highly Linear IF Microelectromechanical Filter.....	35
<i>F. Babazadeh, S. H. Keshmiri</i>	
Design Digital Data Acquisition and Processing Systems for Embedded System	44
<i>Maksym Antonyuk, Mykhaylo Lobur, Volodymyr Antonyuk</i>	
Design of Precise Analog Frequency Multipliers of Harmonic Signals in Even Number of Times.....	51
<i>Pavlo V. Tymoshchuk</i>	
Discrete models of oscillating systems and their applications.....	55
<i>Vasyl Zayats, Mykhaylo Lobur</i>	
Effect of Annealing on Optical and Band Gap Alignments of CdTe Thin Films Prepared by Pulsed Laser Deposition	59
<i>V.Savchuk, B.Kotlyarchuk, A.Zaginey, R.Lesyuk, M.Oszwaldowski</i>	
Features of the Nature-Language Interface for Physical Quantities Measurement Sensors Database Design Development.....	62
<i>Grigoryev V.V., Panchak R.T.</i>	
Grounding of Neurons Networks Application for the Decision of the Applied Tasks	63
<i>Iryna Yurchak</i>	
Image Preprocessing for Improving OCR Accuracy.....	65
<i>Wojciech Bieniecki, Szymon Grabowski, Wojciech Rozenberg</i>	
Increasing of the embedded system measuring module accuracy	71
<i>Ulyana Marikutsa</i>	
Methodology of the Automated MEMS Design.....	74
<i>Vasyl Teslyuk, Mykhaylo Lobur, Pavlo Denysyuk, Konstantin Kolesnyk</i>	
Micro Milling Technologies for MEMS	76
<i>Jinsheng Wang, Yadong Gong, Garbriel Abba, Jianfeng Cao, Jiashun Shi, Guangqi Cai</i>	
Model and Analysis of Signal Conditioning Circuit of Capacitive Microaccelerometer.....	86
<i>Roman-Andriy Ivanciv, Roman Zaharyuk, Vasyl Teslyuk</i>	

Table of Contents

Modern OCR construction approaches and ill-conditioned problem theory.....	88
<i>Imad I. A. Sbieh</i>	
Motion Analysis in Automatic Systems.....	90
<i>Valentin Abakumov, Olena Lomakina</i>	
Network microresonator: modeling and simulations	94
<i>T. Sviridova, L. Sviridova</i>	
Overview of the Modern State of the Vibration Energy Harvesting Devices.....	97
<i>Mykola Pereyma</i>	
Perspectives of Smart RFID Tags Usage Fabricated by MEMS Technologies	103
<i>Mykola Pereyma, Ihor Motyka, Mykhaylo Lobur</i>	
Principles of Intellectual Database Design for Electronic Secure Sensors.....	104
<i>Grigoryev V.V., Panchak R.T.</i>	
Research of Influence of Materials Properties on Resonance Frequencies of Micromechanical Tuning Fork Gyroscope.....	105
<i>Mykhaylo Lobur, Andriy Holovatyy</i>	
Simulation of Electromechanical Systems Driven by Large Random Vibrations	107
<i>Einar Halvorsen, Lars-Cyril Julin Blystad, Svein Husa, Eskild Westby</i>	
The Analysis of design Management Task in Distributed MEMS CAD Tools.....	113
<i>Mykhaylo Lobur, Olga Lebedeva, Oleh Matviyukiv</i>	
The Calculation of Signal Delay in the Semiconductors Integral Integrated Chip.....	117
<i>Sergiy Ivchuk, Ivan Kostyuk, Mykola Pereyma</i>	
The Control Unit of PCI Bus	118
<i>Antonyuk V.P., Klepfer E.I., Lobur M.V., Zaharko J.M., Pereyma M. Y.</i>	
The Development of Model for Parameters for MEMS' Operating Reliability Determination	121
<i>Mykhaylo Melnyk, Vasyl Teslyuk, Ihor Farmaha, Volodymyr Karkulyovskyy, Svitlana Moroz</i>	
The formalization of the MEMS automated design process by usage of Petri Networks.....	123
<i>Vasyl Teslyuk, Hamza Al-Shababkeh, Mykola Pereyma, Al Omari Tarik</i>	
The method of solid-liquid contact angle measurement using the images of sessile drops with shadows on substratum.....	125
<i>Jaroslaw Goclawski, Wieslawa Urbaniak-Domagala</i>	
The Microelectronic Devices Failure Diagnostics	131
<i>Sergiy Ivchuk, Vasyl Kogut, Volodymyr Karkulyovskyy</i>	
Trade-Off between Issues in AlN/SiO₂/Si Pressure Sensor	132
<i>Hoang Trang, Benech Philippe, Rey Patrice, Vaudaine Marie-Helene, Lemaitre-Augier Pierre, Danel Jean-Sébastien, Robert Philippe</i>	
Usage of XML for Fluidic MEMS Database Design	138
<i>Pavlo Denysyuk</i>	
Using Petri Nets in Capacitive Microaccelerometers Design	139
<i>Roman Zaharyuk, Vasyl Teslyuk, Volodymyr Karkulyovskyy</i>	
VLSI Topology Synthesis Using the Method of Parallel Genetic Algorithms	141
<i>Andriy Kernytsky, Rostyslav Kryvyy, Serhiy Tkatchenko</i>	
Ways to Establishing Necessary Features of Circuits Equivalence	143
<i>Bilal Al-Zabi, Andriy Kernytsky, Serhiy Tkachenko</i>	
Yarn hairiness determination – the algorithms of computer measurement methods.....	144
<i>Marcin Kuzanski, Lidia Jackowska-Strumillo</i>	